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The following <u>Listing of the Claims</u> will replace all prior versions and all prior listings of the claims in the present application:

- 1. (Currently Amended): A micro-dimensional probe comprising:
  - a) an electrode pair array attached to a substrate material;
  - b) a <u>branched</u> nanotube <u>cantilever comprising</u>: <del>array configured in a cantilever</del> arrangement comprising a plurality of microparticulate ferromagnetic materials attached to the electrode array; and
    - i) at least one ferromagnetic material; and
  - ii) at least two tubules attached to the electrode pair; and
  - c) an electrical circuit coupling the electrode pair array to a probe component.
- 2. (Currently Amended): The micro-dimensional probe of claim 1, wherein the <u>branched</u> nanotube cantilever exhibits piezoresistance.

Claim 3 cancelled.

- 4. (Currently Amended): The micro-dimensional probe of claim 3 1, wherein the <u>branched</u> carbon nanotube <u>cantilever</u> emprises at least one tubule with <u>has</u> a Y-shaped or V-shaped morphology.
- 5. (Currently Amended): The micro-dimensional probe of claim 3 1, wherein the <u>branched</u> carbon nanotube <u>cantilever</u> has a multi-walled morphology.
- 6. (Currently Amended): The micro-dimensional probe of claim 4 1, wherein the tubules have has a diameter ranging between 1 nanometer and 100 nanometers.
- 7. (Currently Amended): The micro-dimensional probe of claim 4 1, wherein the tubules have has a diameter ranging between 1 nanometer and 50 nanometers.

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8. (Currently Amended): The micro-dimensional probe of claim 4, wherein the Y-shaped or V-shaped morphology comprises a tubules having a length ranging between 0.1 micrometer and 100 micrometers.

- 9. (Currently Amended): The micro-dimensional probe of claim 4, wherein the Y-shaped or V-shaped morphology comprises a tubules having a length ranging between 1 micrometer and 10 micrometers.
- 10. (Original): The micro-dimensional probe of claim 1, wherein the ferromagnetic material comprises at least one transition metal.
- 11. (Original): The micro-dimensional probe of claim 10, wherein the transition metal is selected form the group consisting of iron, cobalt, nickel and combinations and alloys thereof.
- 12. (Original): The micro-dimensional probe of claim 1, that is part of a microscopic imaging device.
- 13. (Original): The micro-dimensional probe of claim 12, having a nanoscale dimension.
- 14. (Original): The micro-dimensional probe of claim 13, wherein the microscopic imaging device is an MFM or MRFM device.
- 15. (Original): The micro-dimensional probe of claim 14, that provides detection with nanoscale resolution.

Claims 16-43 cancelled.

- 44. (Original): A method of sensing or manipulating a microscopic environment or structure using the micro-dimensional probe of claim 1, comprising:
  - a) passage of an electric current through the micro-dimensional probe; and

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b) detecting a cantilever tip motion generated by the electric current passage through the micro-dimensional probe by measuring a change in piezoresistance upon deflection from the surface of a sample.

- 45. (New): The micro-dimensional probe of claim 1 comprising a plurality of branched carbon nanotube cantilevers arranged in an array.
- 46. (New): The microdimensional probe of claim 1 wherein the branched nanotube cantilever is a branched carbon nanotube cantilever.
- 47. (New): The microdimensional probe of claim 1 wherein the ferromagnetic is a material is a magnetic sensor material.